2822

PTO/SB/21 (09-04) Approved for use through 07/31/2006. OMB 0651-0031 U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE aperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number. Application Number 10/072.357 **TRANSMITTAL** Filing Date 02/06/2002 First Named Inventor **FORM** Michael D. Kilgore Art Unit 2822 Examiner Name Maria F. Guerrero (to be used for all correspondence after initial filing) Attorney Docket Number NVS014 US Total Number of Pages in This Submission

Total residue of Fagger III File Cashinates							
ENCLOSURES (Check all that apply)							
		smittal Form		Drawing(s) Licensing-related Papers			After Allowance Communication to TC Appeal Communication to Board of Appeals and Interferences
Amendment/Reply After Final Affidavits/declaration(s) Extension of Time Request Express Abandonment Request Information Disclosure Statement Certified Copy of Priority Document(s) Reply to Missing Parts/ Incomplete Application Reply to Missing Parts under 37 CFR 1.52 or 1.53		Petition Petition to Convert to a Provisional Application Power of Attorney, Revocation Change of Correspondence Address Terminal Disclaimer Request for Refund CD, Number of CD(s) Landscape Table on CD Remarks Please charge any required fee(s) to Deposit Act			Appeal Communication to TC (Appeal Notice, Brief, Reply Brief) Proprietary Information Status Letter Other Enclosure(s) (please Identify below): Return Postcard		
SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT							
Firm Name Silicon Valley Patent Grou							
Signature		Marcal 5 Stoute					
Printed name		David E. Steuber					
Date		05/27/2006 Reg. No. 25,557					7

CERTIFICATE OF TRANSMISSION/MAILING

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class maintimen envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date shown below:

Signature

David E. Steuber

Date 05/27/2006

This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.11 and 1.14. This collection is estimated to 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.

10/072,357

Confirmation No. 4288

First Inventor

Michael D. Kilgore

Filing Date

2/6/2002

Tech. Center/

2822

Examiner

Maria F. Guerrero

Art Unit

Title:

High Density Plasma Process For Optimum Film Quality And

Electrical Results

Docket No.:

NVS014 US

Customer No.:

34036

Santa Clara, California May 27, 2006

Mail Stop Amendment **COMMISSIONER FOR PATENTS** P.O. Box 1450 Alexandria, VA 22313-1450

<u>AMENDMENT</u>

Dear Sir:

In response to the Office Action dated February 28, 2006, please amend the aboveidentified application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.